

Applicant: Johnny Zhong et al.
Serial No.: 10/698,581
Filing Date: October 31, 2003
For: THIN FILM INTERLEAVER

Confirmation No.: 1109
Att'y Docket No.: 15436.132.1
Group: 2874

References Cited by Applicants

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

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The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

U.S. Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>
____ 1	6,421,177	07/16/2002	Leyva et al.
____ 2	6,256,433	07/03/2001	Luo et al.

Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country or Patent Office</u>	<u>Translation</u>
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Other Documents

(including author, title, pertinent pages, etc.)

<u>Examiner Initial*</u>	
____ 3	Nick Herring, <i>The E-Tek Interleaver with Lowest Dispersion</i> , BFi OPTiLAS, June 20, 2000.
____ 4	Stephane Bourgeois, <i>Fused-Fiber Developments: Offer Passive Foundation for Optical Slicing</i> , Lightwave Special Report, March 4, 2000.
____ 5	Joseph C. Chon et al., <i>Ultra-high Capacity and High Speed DWDM Optical Devices for Telecom and Datacom Application</i> , Proceedings of SPIE, Vol. 4581, 2001, pp. 13-20.
____ 6	Wavesplitter Lighting the Internet on Fiber Catalog, <i>Creating Unique Advantages Together</i> , WaveProcessor F ³ T Interleaver, February 2002.

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